



PATENT APPLICATION  
Docket No. 8371-129

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Apostolos Voutsas and Yukihiro Nakata

Serial No. 09/945,063

Examiner: G. R. Fourson III

Confirmation No. 3014

Filed: August 31, 2001

Group Art Unit: 2823

For: METHOD OF FORMING MULTI-LAYERS FOR A THIN FILM TRANSISTOR  
(TFT) AND THE DEVICE FORMED THEREBY

**MAIL STOP FEE AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Responsive to the Office Action, dated February 28, 2003, please amend the application as follows.

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.